

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/510,389 Confirmation No. : 6492  
First Named Inventor : Nobuo ISHII  
Filed : December 14, 2004  
TC/A.U. : 1792  
Examiner : DHINGRA, RAKESH KUMAR  
  
Docket No. : 101248.55500US  
Customer No. : 23911  
  
Title : Plasma Processing System

**REPLY**

**Mail Stop AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Office Action dated March 17, 2008.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.